

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination 10/705,508 CHENG ET AL.	
		Examiner Adam C. Rehm	Art Unit 2875	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0150991	08-2004	Ouderkirk et al.	362/231
*	B	US-6,466,135	10-2002	Srivastava et al.	340/815.4
*	C	US-5,735,595	04-1998	Nederpel et al.	362/223
*	D	US-5,535,230	07-1996	Abe, Tadashi	372/50.23
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	K	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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